

Attorney Docket No. 061063-0356139  
Client Reference: OSP-19398

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: MASATAKA HOURAI, WATARU SUGIMURA and TOSHIAKI ONO

Application No.:

Confirmation No:

Filed: July 24, 2006

Group No.:

Examiner UNASSIGNED

For: SILICON WAFER, METHOD FOR MANUFACTURING THE SAME AND METHOD FOR GROWING SILICON SINGLE CRYSTALS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: MASATAKA HOURAI  
Citizenship: JAPAN  
Residence: Saga-shi, Japan

Second applicant: WATARU SUGIMURA  
Citizenship: JAPAN  
Residence: Saga-shi,, Japan

Third applicant: TOSHIAKI ONO  
Citizenship: JAPAN  
Residence: Saga-shi,, Japan

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: SILICON WAFER, METHOD FOR MANUFACTURING THE SAME AND METHOD FOR GROWING SILICON SINGLE CRYSTALS

Docket number assigned to this application: 061063-0356139

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 12

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: 1

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

#### **4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

#### **5. Domestic Priority information**

Domestic priority for this application is claimed as follows:

35 U.S.C. § 365(c):

Application No.: PCT/JP2005/015346

Filed: August 24, 2005

Status: Pending

Relationship: Parent

#### **6. Foreign priority information**

Foreign priority is claimed for this application as follows:

Country: JP

Application No.: 2004-246017

Filing Date: August 25, 2004

Status: Pending

Country: JP

Application No.: 2005-163152

Filing Date: June 2, 2005

Status: Pending

Country: JP

Application No.: 2005-239529

Filing Date: August 22, 2005

Status: Pending

**7. Assignee information**

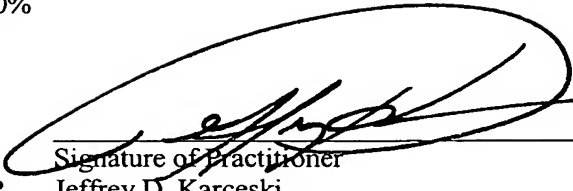
The assignee(s) of this application is/are:

SUMCO CORPORATION  
2-1, Shibaura 1-chome, Minato-ku  
Tokyo,  
Japan

Extent of interest of assignee in application: 100%

Date: July 24, 2006

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